

**Search Notes**

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Examiner

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Applicant(s)/Patent under  
Reexamination

SHIBAYAMA, TAKAMITSU

Art Unit

2817

**SEARCHED**

Class	Subclass	Date	Examiner
333	1.1, 24.2	6/10/2005	SJ

**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

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